

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: **Eun-ae Chung; Ki-hyun Hwang; Jung-hwan Oh; Hyo-jung Kim; Seok-woo Nam; Won-sik Shin; U-in Chung; Young-sun Kim; Hee-seok Kim; Beom-jun Jin**

For: **CAPACITORS OF SEMICONDUCTOR DEVICES INCLUDING SILICON-GERMANIUM AND METALLIC ELECTRODES AND METHODS OF FABRICATING THE SAME**

April 13, 2004

Mail Box Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION FILED UNDER 37 CFR 1.41(c)

Sir:

The above-identified application is being filed on behalf of the inventors, all residents of the Republic of Korea, under the provisions of 37 CFR 1.41(c). A Declaration and Power of Attorney from the inventors will follow, 37 CFR 1.63.

Respectfully submitted,



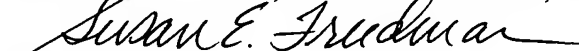
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Susan E. Freedman
Date of Signature: April 13, 2004